

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicants : | Othmar Leitner, et al. | Art Unit | : 2822 |
| Serial No. : | 10/579,487 | Examiner | : Kevin M. Picardat |
| Filed | : May 16, 2006 | Conf. No. | : 3015 |
| Title | : METHOD FOR THE PRODUCTION OF TRANSISTOR STRUCTURES WITH LDD | | |

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO OFFICE ACTION OF OCTOBER 2, 2008

In response to the Office Action of October 2, 2008, please amend the above-identified patent application as follows: